

10/529891

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Application Data Sheet

Application Information

Filing Date:: 4/1/2005 12:00:00AM
Application Type:: Regular
Subject Matter:: Utility
CD_ROM or CD-R?: None
Title:: EXPOSURE MASK, METHOD OF DESIGNING AND
MANUFACTURING THE SAME, EXPOSURE
METHOD AND APPARATUS, PATTERN FORMING
METHOD, AND DEVICE MANUFACTURING
METHOD
Attorney Docket Number:: 00684.003654.
Request for Early Publication:: No
Request for Non-Publication?: No
Total Drawing Sheets:: 7
Small Entity?: No
Petition included:: No
Secrecy Order in Parent Appl.?: No

Applicant Information

Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Takako
Family Name:: YAMAGUCHI
City of Residence:: Atsugi-shi
Country of Residence:: Japan
Primary Citizenship Country:: Japan
Given Name:: Yasuhisa
Family Name:: INAO

City of Residence:: Kawasaki-shi

Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 5514

Representative Information

Representative Customer Number::	05514
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Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National stage of	PCT/JP2004/009375	06/25/2004

Foreign Priority Information

Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2003-182041	06/26/2003	Yes
Japan	2004-097699	03/30/2004	Yes

Assignee Information

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